

PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q92479

Tsuyoshi UEHARA, et al.

Appln. No.: 10/565,004

Group Art Unit: 1709

Confirmation No.: 5166

Examiner: Keath T CHEN

Filed: January 19, 2006

For: PLASMA PROCESSING APPARATUS AND ELECTRODE STRUCTURE

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated July 25, 2007, please amend the above-identified application as follows on the accompanying pages.

TABLE OF CONTENTS

AMENDMENTS TO THE CLAIMS	2
AMENDMENTS TO THE DRAWINGS	17
REMARKS	18